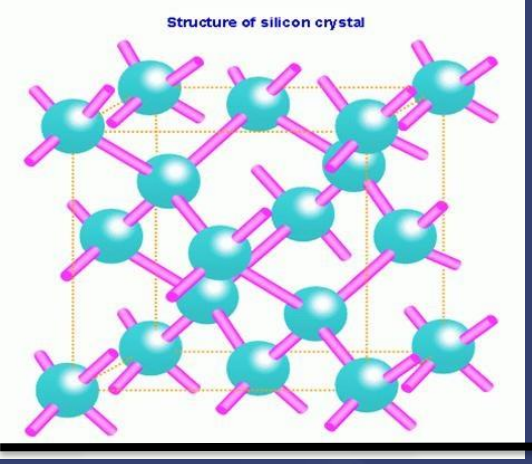
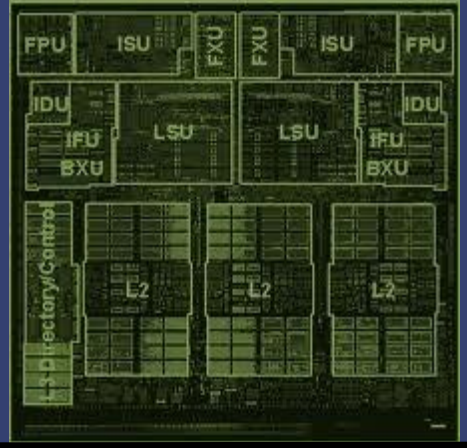
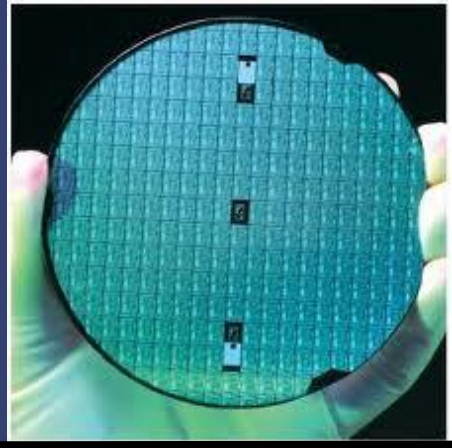






ECE 225

Lecture 13

Nanoscale Power and Thermal Management:

Self-consistent Thermal Profile Estimation

Design-Specific Metric Optimization

IC Cooling Analysis

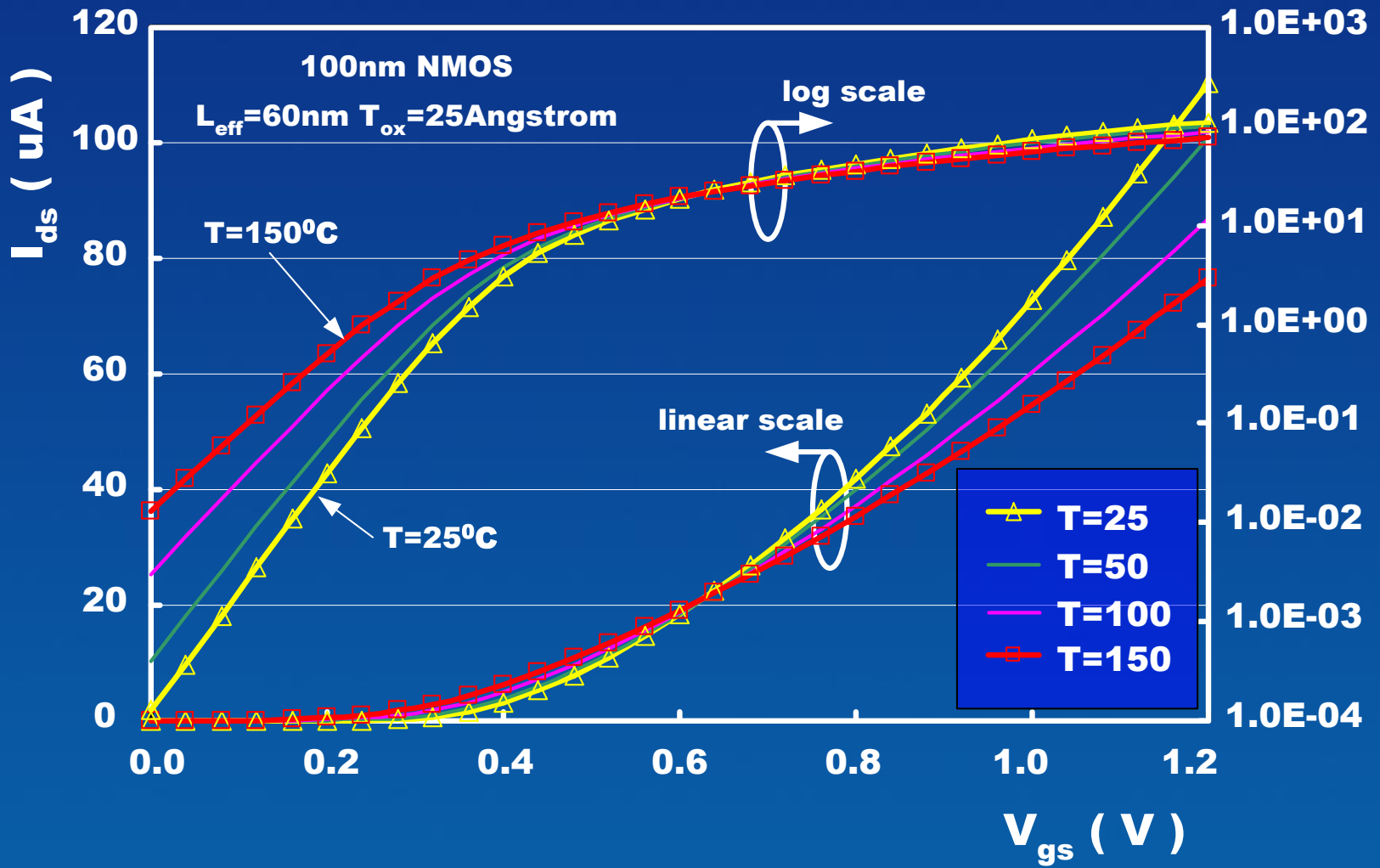
Prof. Kaustav Banerjee
Electrical and Computer Engineering
University of California, Santa Barbara

Self-Consistent Temperature Profile Estimation

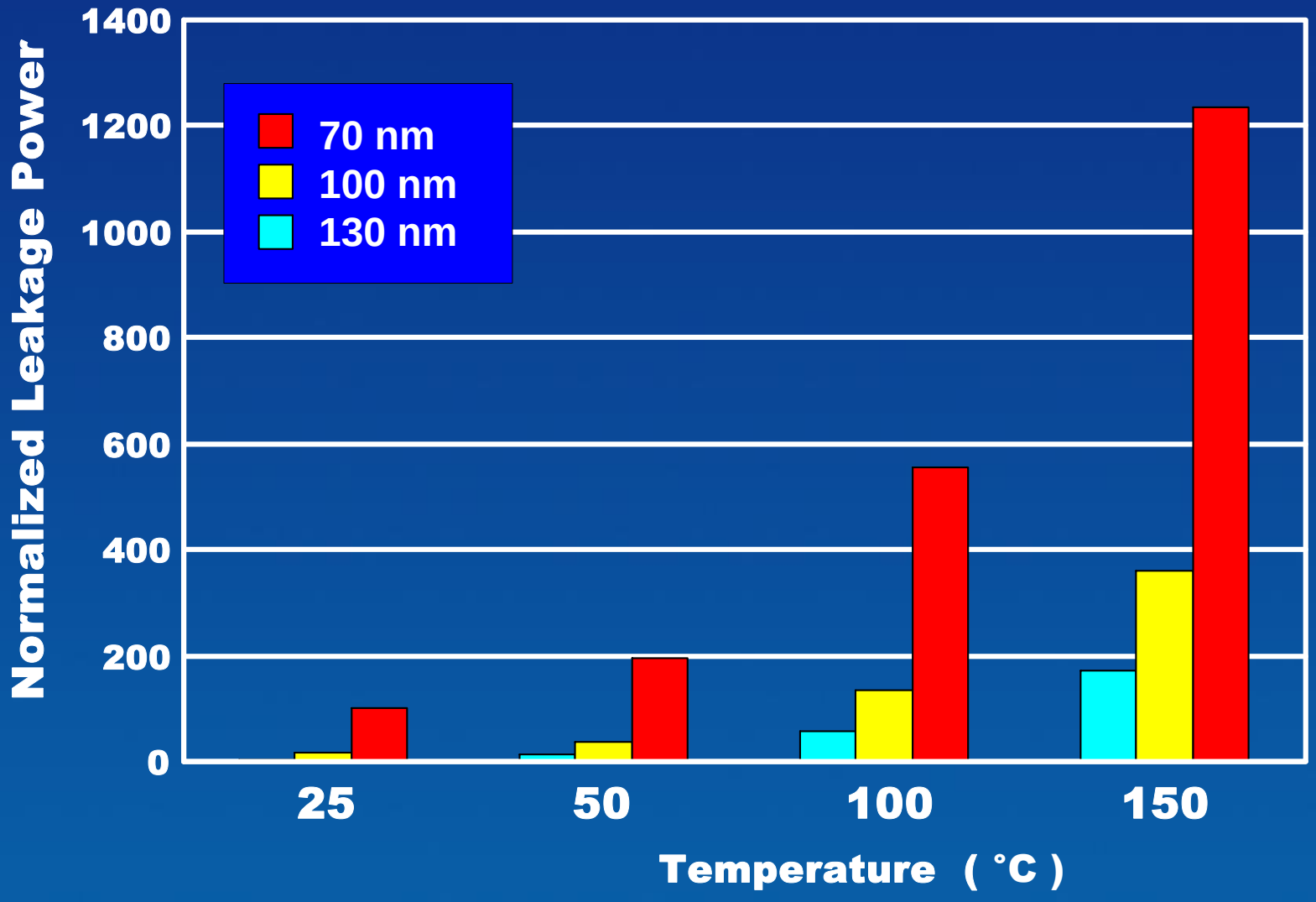
S-C. Lin, G. Chrysler, R. Mahajan, V. De and K. Banerjee, “A Self-Consistent Substrate Thermal Profile Estimation Technique for Nanoscale ICs—Part I: Electrothermal Couplings and Full-Chip Package Thermal Model,” TED Vol. 54, No. 12, pp. 3342-3350, 2007.

S-C. Lin, G. Chrysler, R. Mahajan, V. De and K. Banerjee, “A Self-Consistent Substrate Thermal Profile Estimation Technique for Nanoscale Part II: Implementation and Implications for Power Estimation and Thermal Management,” TED Vol. 54, No. 12, pp. 3351-3360, 2007.

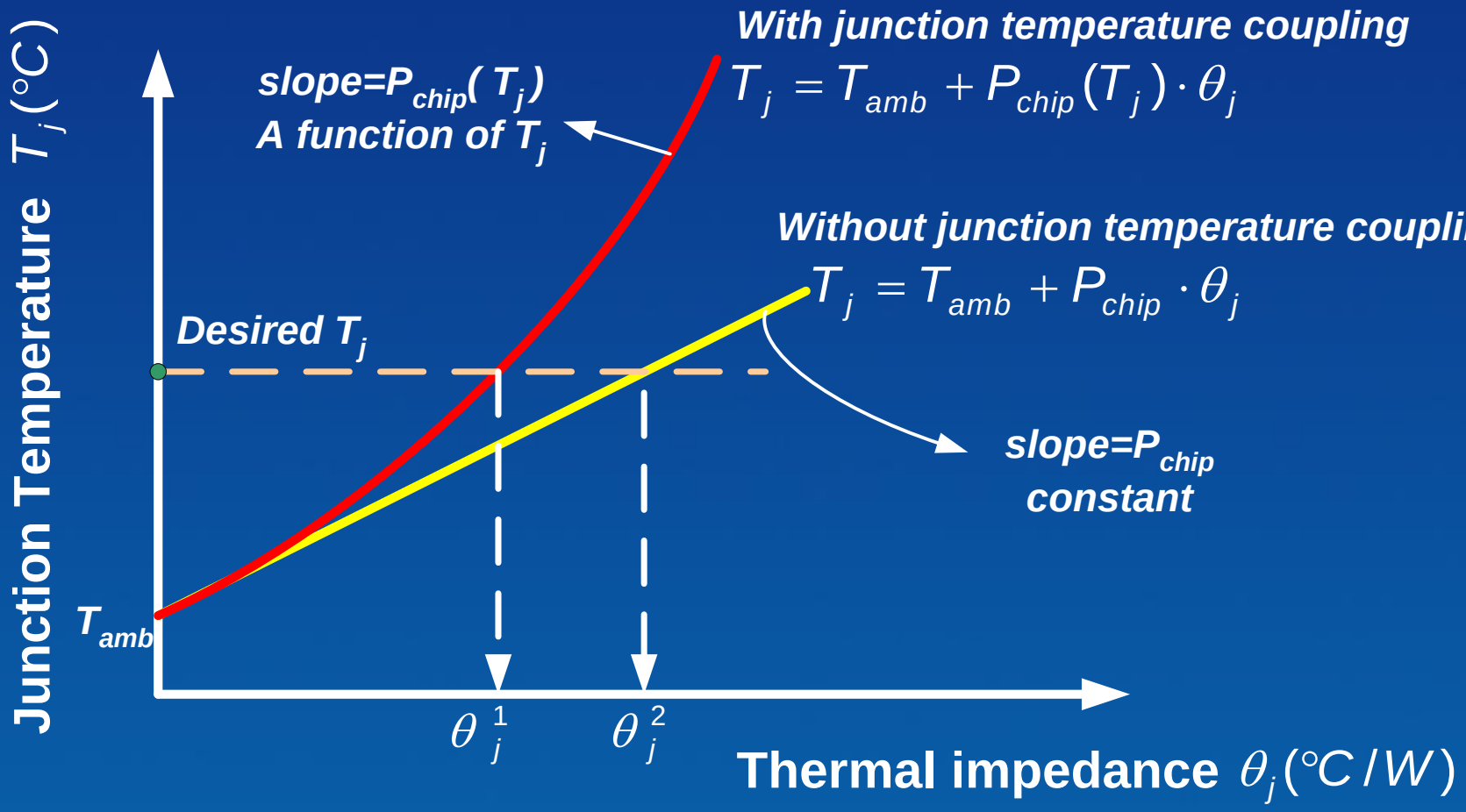
Subthreshold Leakage Current



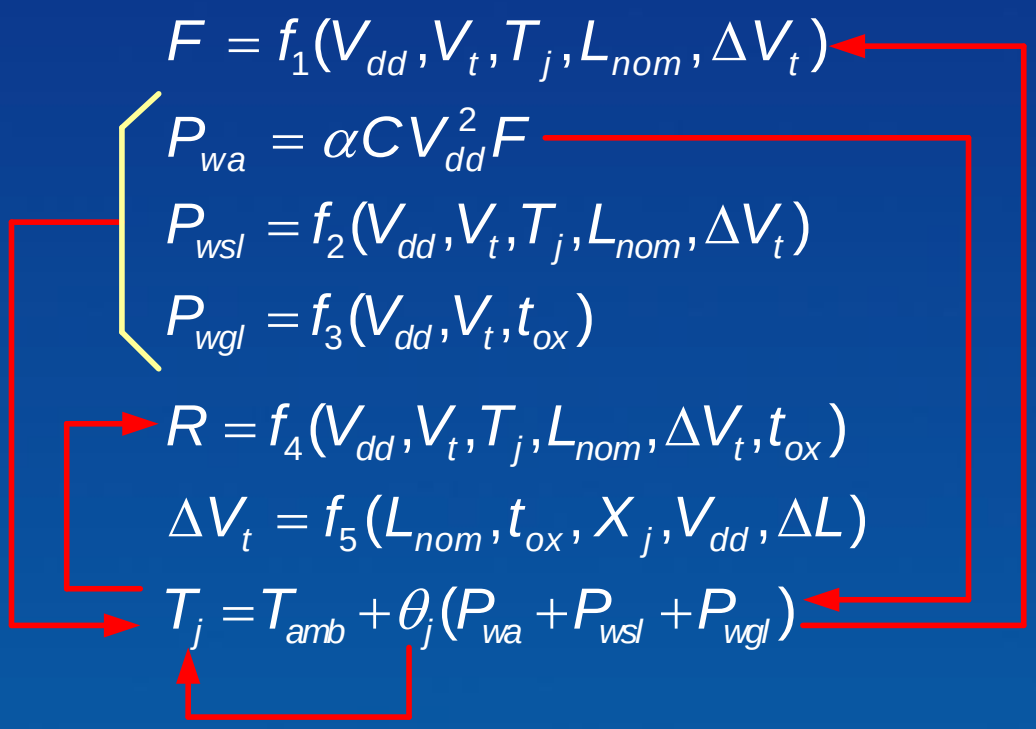
Leakage Power Scaling



P_{chip} dependency



Coupling Models



F → **Frequency**

P_{wa} → **Active Power**

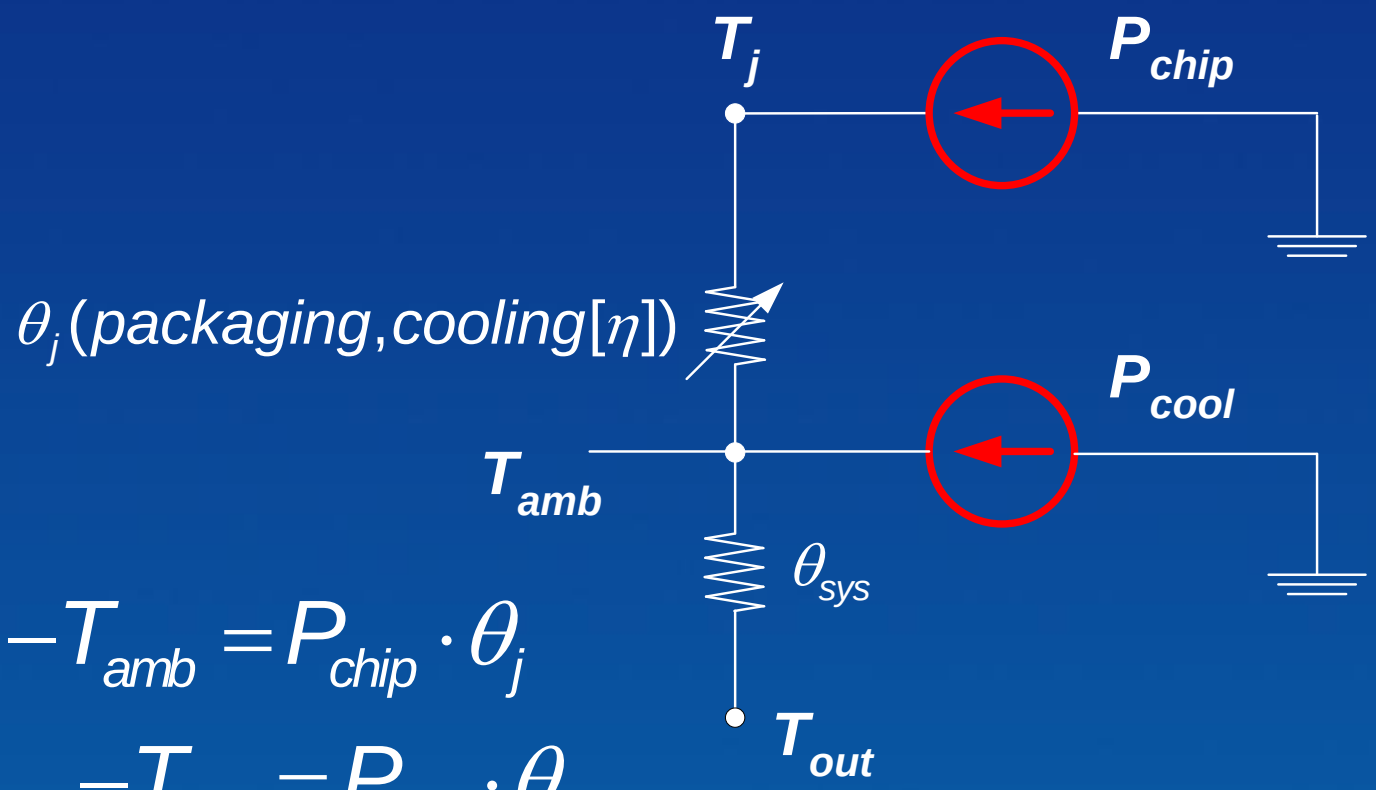
P_{wsl} → **Subthreshold Leakage**

P_{wgl} → **Gate Leakage**

R → **Reliability Factor**

ΔV_t → **Threshold Voltage Variation**

Equivalent Thermal Circuit

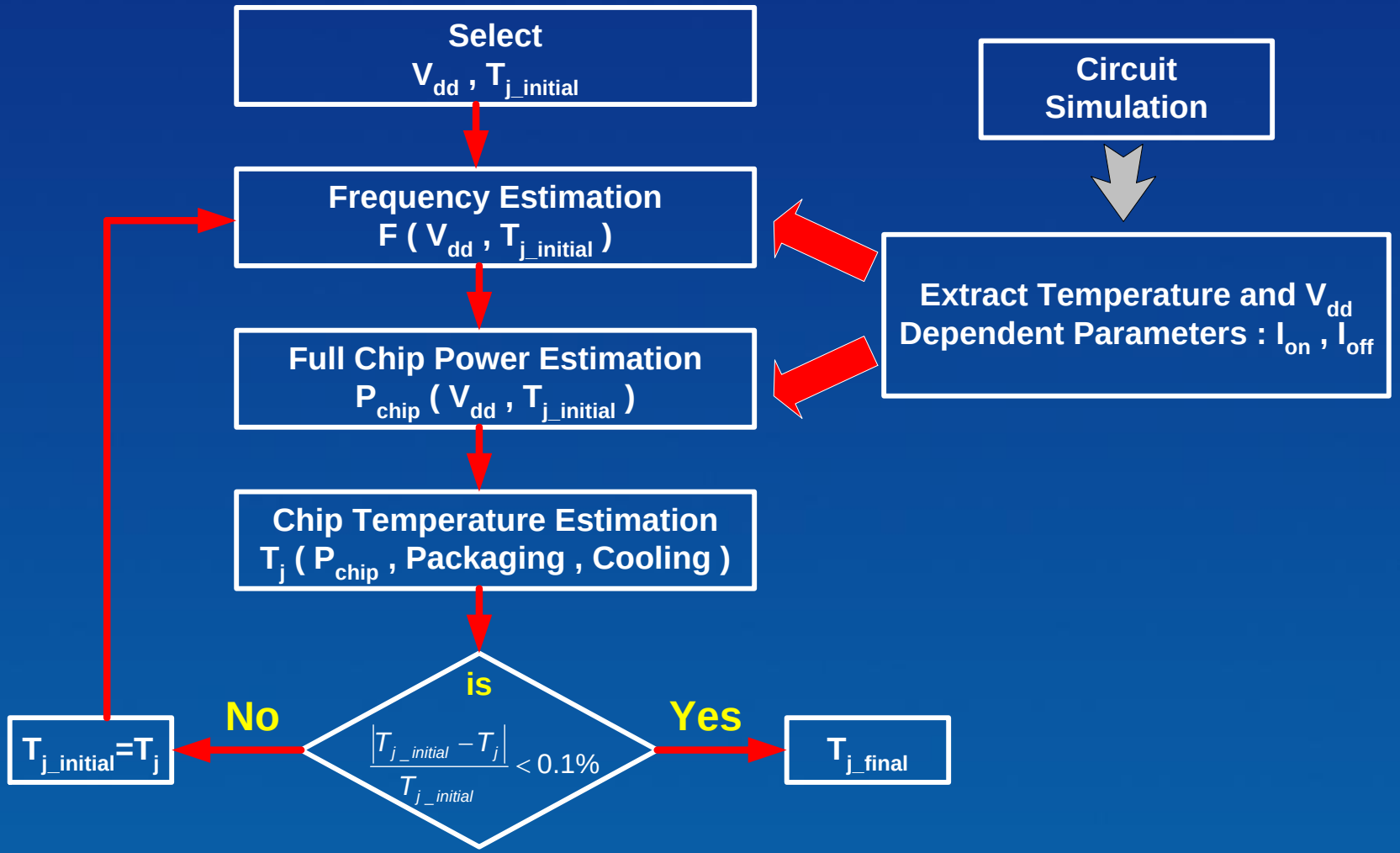


$$T_j - T_{amb} = P_{chip} \cdot \theta_j$$

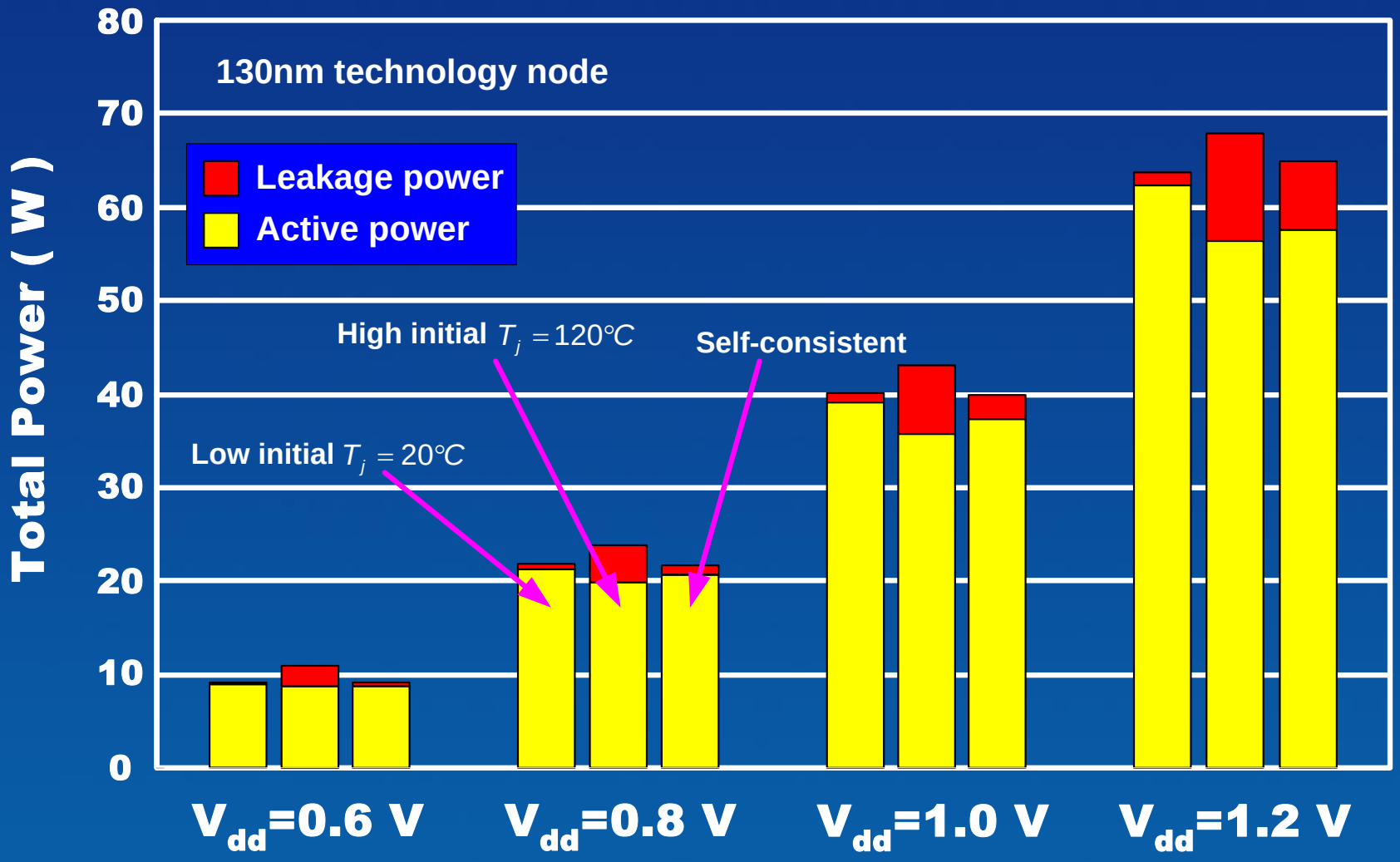
$$T_{amb} - T_{out} = P_{sys} \cdot \theta_{sys}$$

$$P_{sys} = P_{chip} + P_{cool} \quad P_{chip} + (1-\eta)P_{chip} = (2-\eta)P_{chip}$$

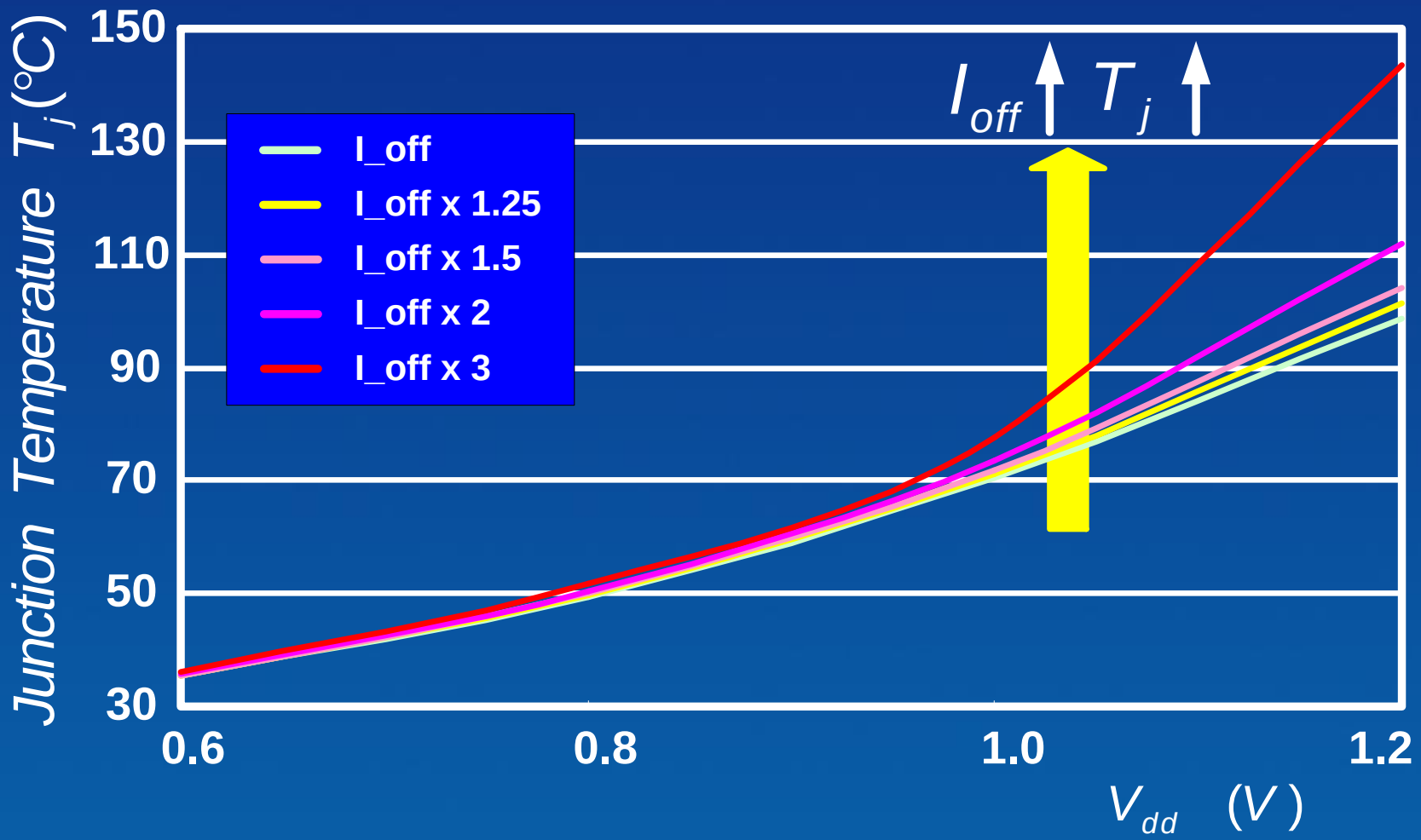
Overview


Select
V_{dd} , $T_{j\_initial}$
Circuit Simulation
Frequency Estimation
$F (V_{dd} , T_{j\_initial})$
Extract Temperature and V_{dd} Dependent Parameters : I_{on} , I_{off}
Full Chip Power Estimation
$P_{chip} (V_{dd} , T_{j\_initial})$
Chip Temperature Estimation
$T_j (P_{chip} , Packaging , Cooling)$
is
$\frac{|T_{j\_initial} - T_j|}{T_{j\_initial}} < 0.1\%$
No
Yes
$T_{j\_initial}=T_j$
T_{j_final}

Total Power Dissipation

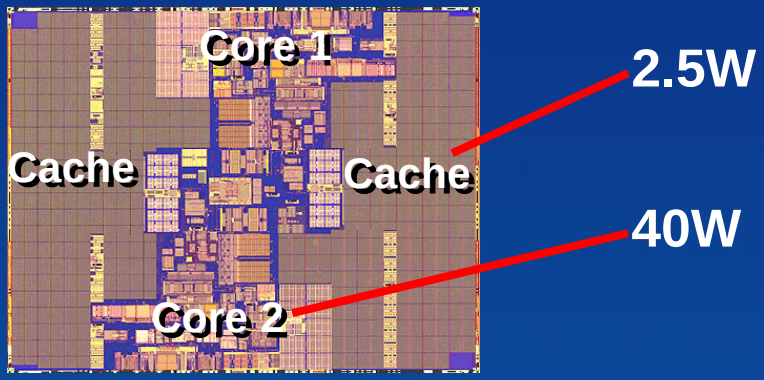


Self-Consistent Junction Temperature

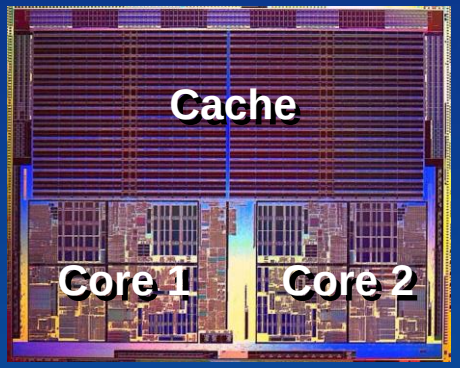


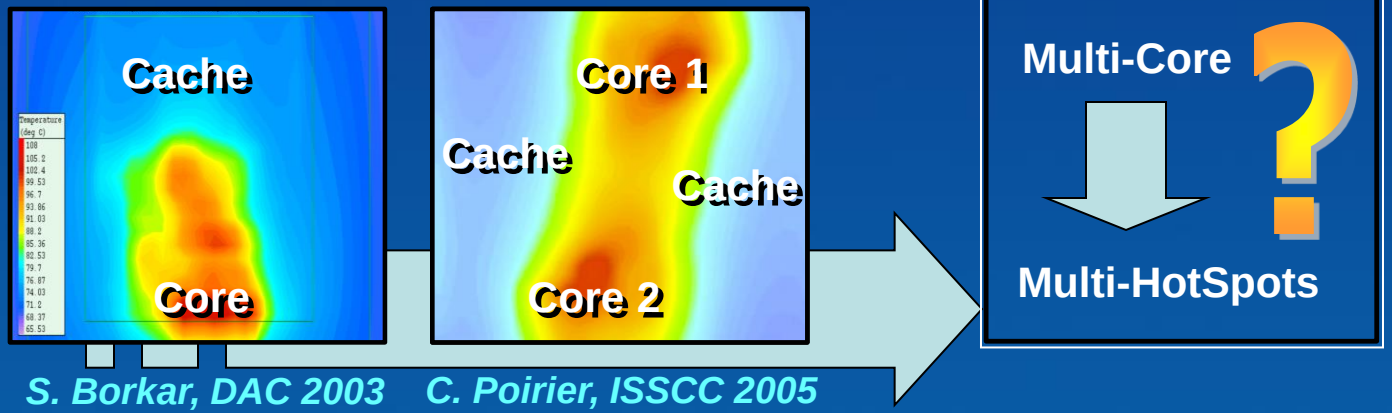
Non-Uniform Power Density

Intel's first dual-core Itanium-Montecito 90nm



AMD's first dual-core Athlon 64 X2 90nm SOI



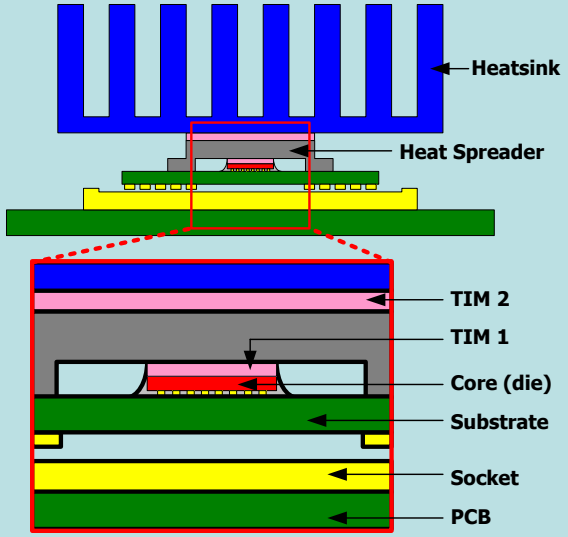


S. Borkar, DAC 2003 *C. Poirier, ISSCC 2005*

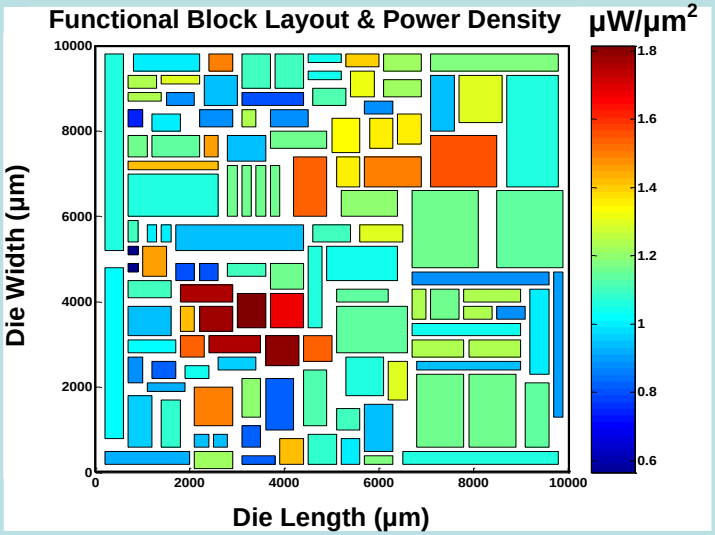
Non-uniform power density generates on-chip temperature gradient

Methodology Overview

Packaging / Cooling Model



Layout Geometry & Power Dissipation



$$\frac{\partial T}{\partial n_i} = \frac{h}{K}[T - T_{amb}]$$

$$\frac{\partial T}{\partial t} = \left(\frac{K}{\rho C_p}\right)\left(\frac{\partial^2 T}{\partial x^2} + \frac{\partial^2 T}{\partial y^2} + \frac{\partial^2 T}{\partial z^2}\right) + \frac{p}{\rho C_p}$$

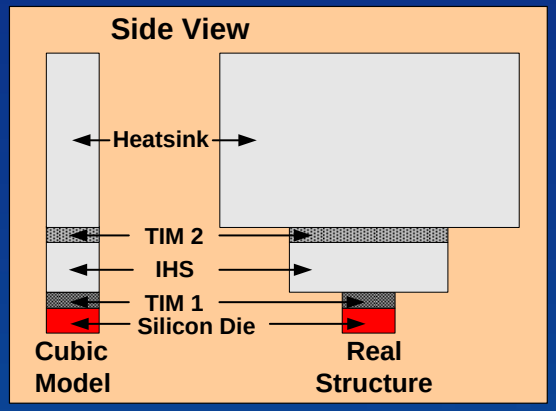
Boundary Condition

Parabolic Heat Partial Differential Equations

Electrothermal Couplings

3-D Electrothermally-Aware Spatial Temperature Estimation

Numerical Approach



$$\frac{\partial T}{\partial t} = \frac{k}{\rho C_p}\left(\frac{\partial^2 T}{\partial x^2} + \frac{\partial^2 T}{\partial y^2} + \frac{\partial^2 T}{\partial z^2}\right) + \frac{p}{\rho C_p}$$

$$\beta_x = \frac{k\Delta t}{2\Delta x^2 \rho C_p}$$

Crank-Nicholson Implicit Method

$$\frac{M_x T}{\Delta x^2} = \frac{T_{i+1,j,k} - 2T_{i,j,k} + T_{i-1,j,k}}{\Delta x^2}$$

$$\frac{\partial^2 T}{\partial x^2} = \frac{1}{2}\left(\frac{M_x T^{n+1}}{\Delta x^2} + \frac{M_x T^n}{\Delta x^2}\right)$$

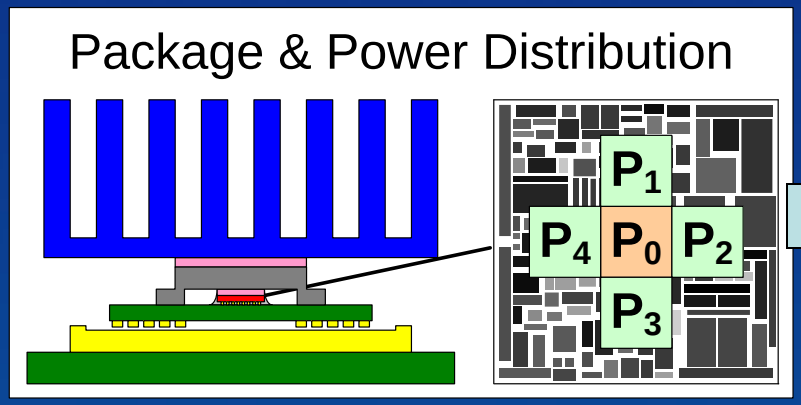
$$\frac{T^{n+1} - T^n}{\Delta t} = \left(\frac{k}{\rho C_p}\right)\left[\left(\frac{M_x}{2\Delta x^2} + \frac{M_y}{2\Delta y^2} + \frac{M_z}{2\Delta z^2}\right)\left(T^{n+1} + T^n\right)\right] + \frac{p}{\rho C_p}$$

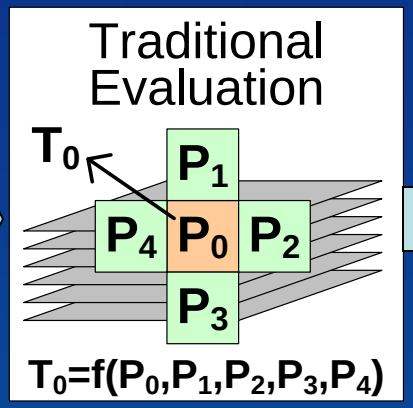
$$(1 - \beta_x M_x - \beta_y M_y - \beta_z M_z)(T^{n+1} - T^n) = 2(\beta_x M_x + \beta_y M_y + \beta_z M_z)T^n + \frac{\Delta t}{\rho C_p} p$$

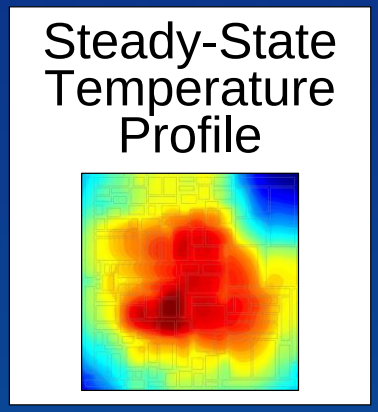
$$(1 - \beta_x M_x)(1 - \beta_y M_y)(1 - \beta_z M_z)(T^{n+1} - T^n) = 2(\beta_x M_x + \beta_y M_y + \beta_z M_z)T^n + \frac{\Delta t}{\rho C_p} p$$

Linear Equations: $(1 - \beta_x M_x)U_{x,y,z} = V_{x,y,z}$

Self-Consistent Evaluation

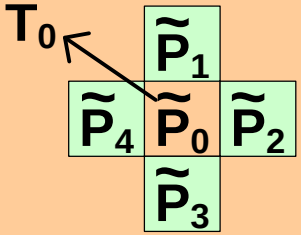






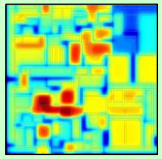
Update temperature dependent power

Self-Consistent Evaluation



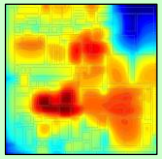
$T_0=f(\tilde{P}_0,\tilde{P}_1,\tilde{P}_2,\tilde{P}_3,\tilde{P}_4)$

From $P(t_0)$ Solve $T(t_0+\Delta t)$



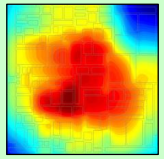
$P(t_0) \rightarrow P(t_0+\Delta t)$

From $P(t_0+\Delta t)$ Solve $T(t_0+2\Delta t)$



$P(t_0+\Delta t) \rightarrow P(t_0+2\Delta t)$

Steady-State Temperature profile

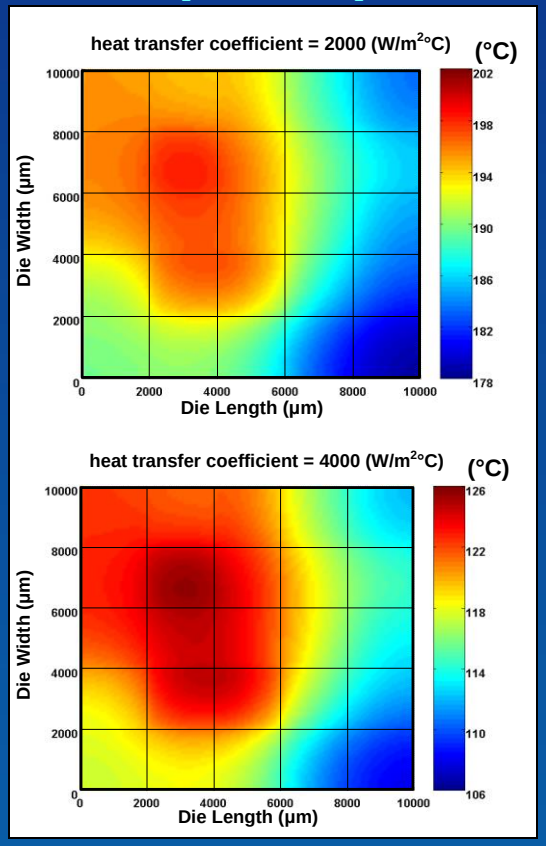


Steady-State P

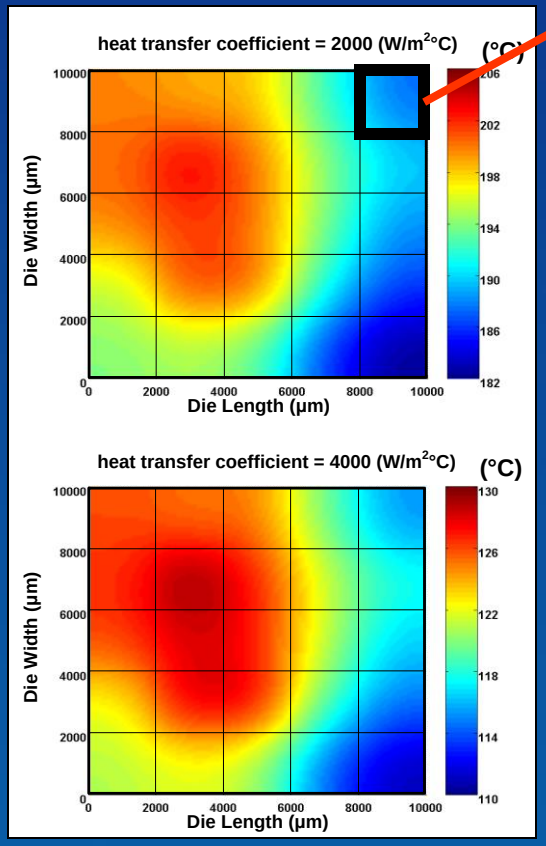
Methodology Verification

For a case with negligible leakage

Commercial Tool (IcePak)



Proposed Method

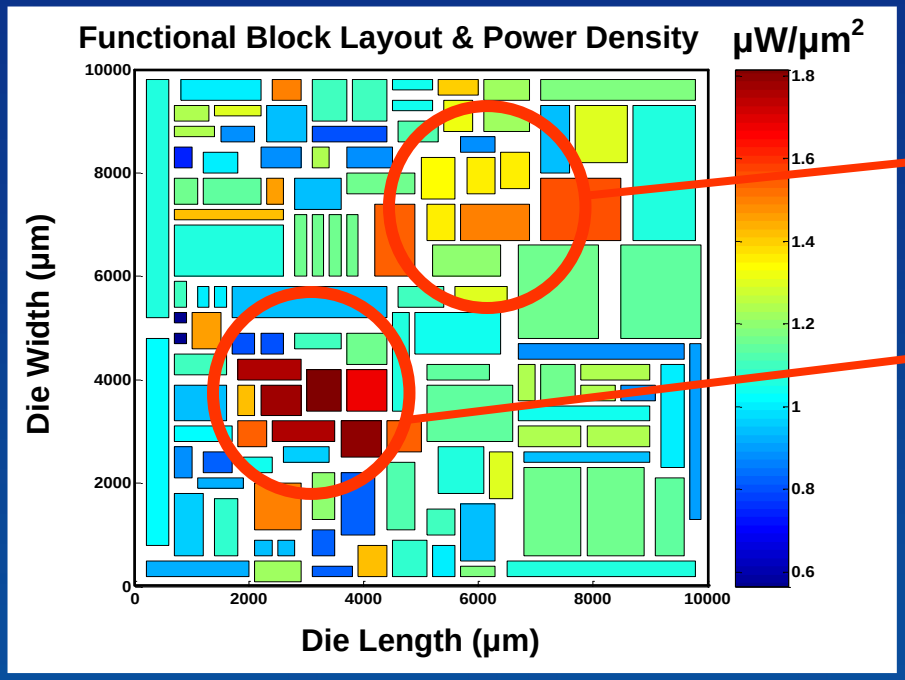


Equally select 400 data points from identical locations for comparison (total = 10000 pts)

Coefficient	Max. Deviation
h=1000	2.13 %
h=2000	2.48%
h=3000	3.26 %
h=4000	3.28 %
h=5000	3.06 %

Proposed method is validated against an industrial-quality software.

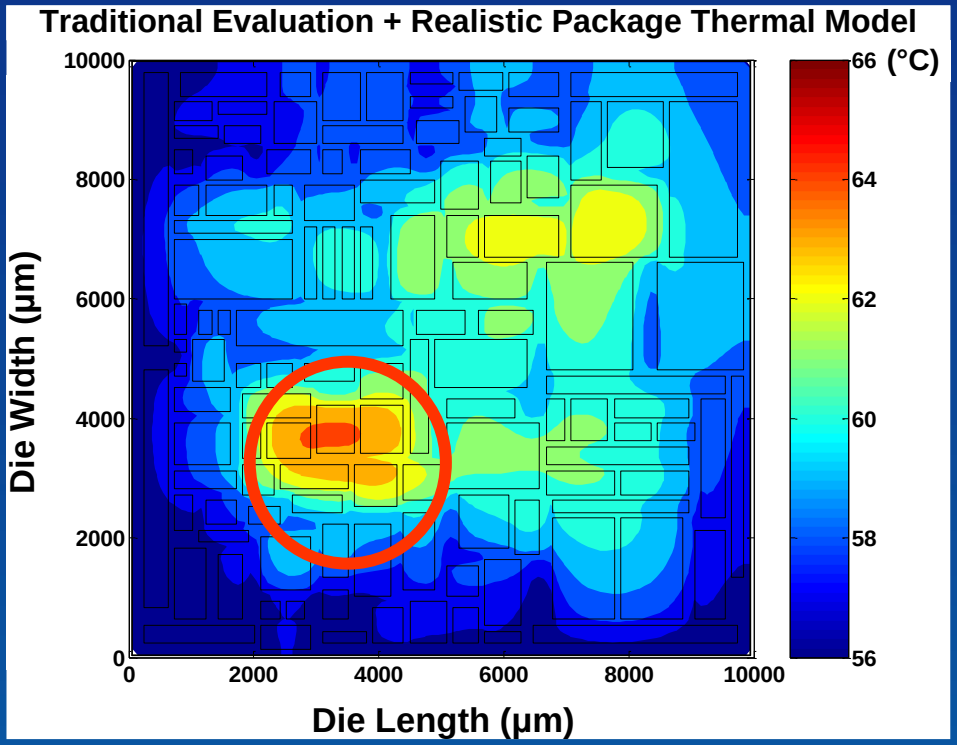
Implementation & Setup



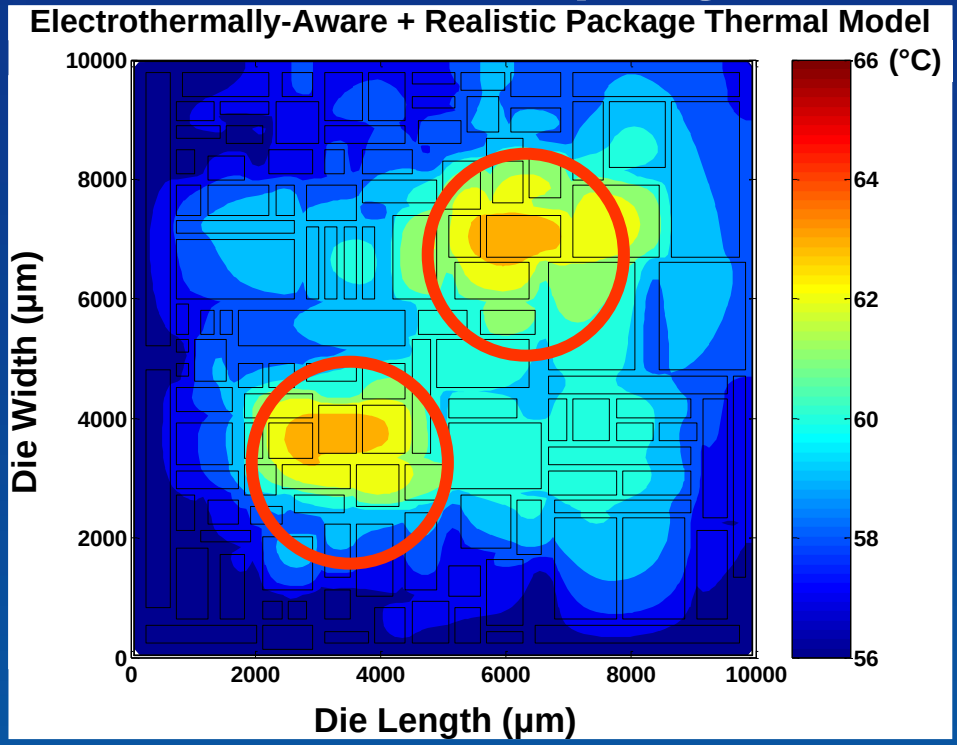
Layer	Area (mm^2)	Thickness (mm)	Specific Heat (J/kg°C)	Density (kg/m^3)	K (W/m°C)
Die	10 X 10	0.8	712	2330	120
TIM 1	10 X 10	0.2	230	7310	30
IHS	30 X 30	1.8	385	8930	390
TIM 2	30 X 30	0.2	2890	900	6.4
Heatsink	60 X 60	6.4	385	8930	360

Impact of Considering ET-couplings

Without ET-Couplings



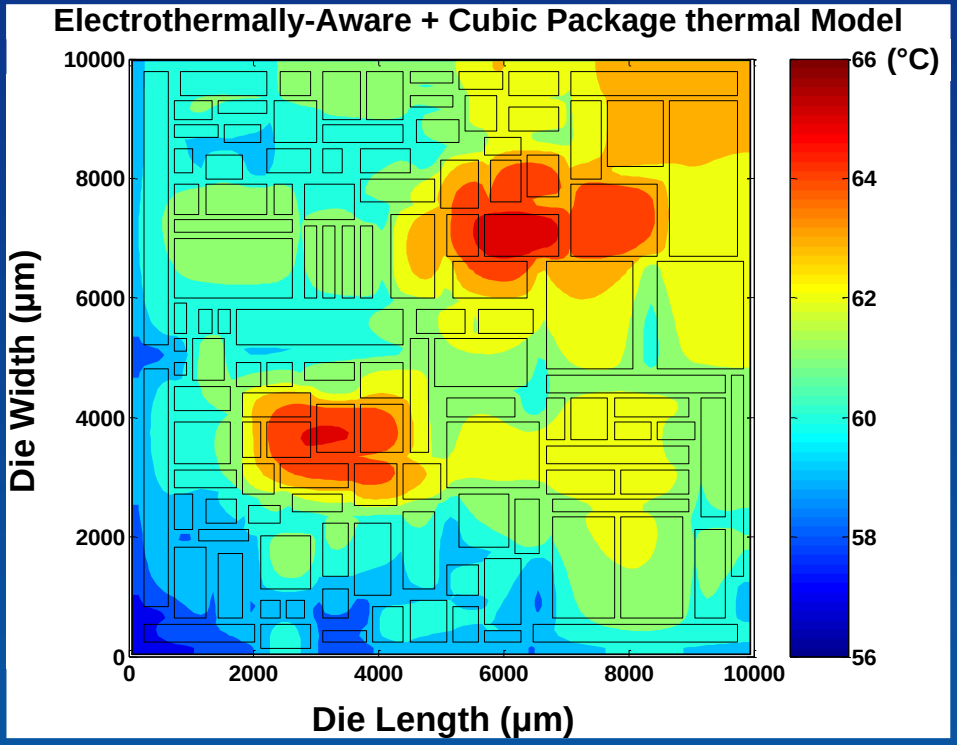
With ET-Couplings



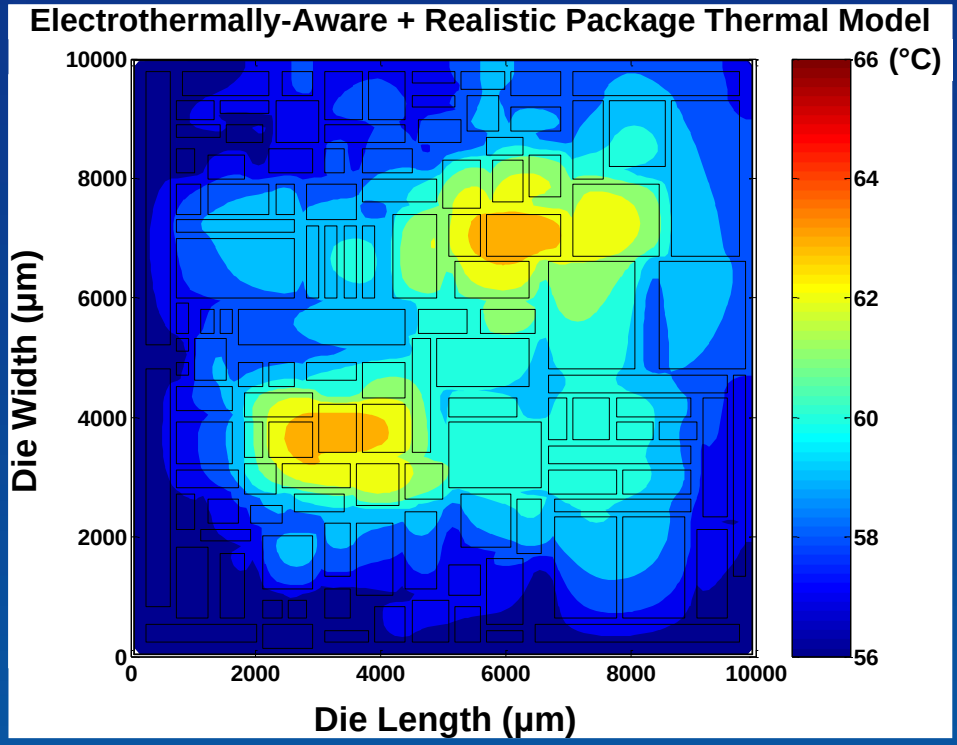
- Traditional evaluation neglects electrothermal couplings
- Considering electrothermal couplings leads to an additional hot-spot at the highest leakage power region

Impact of Package Models

Cubic Package Thermal Model

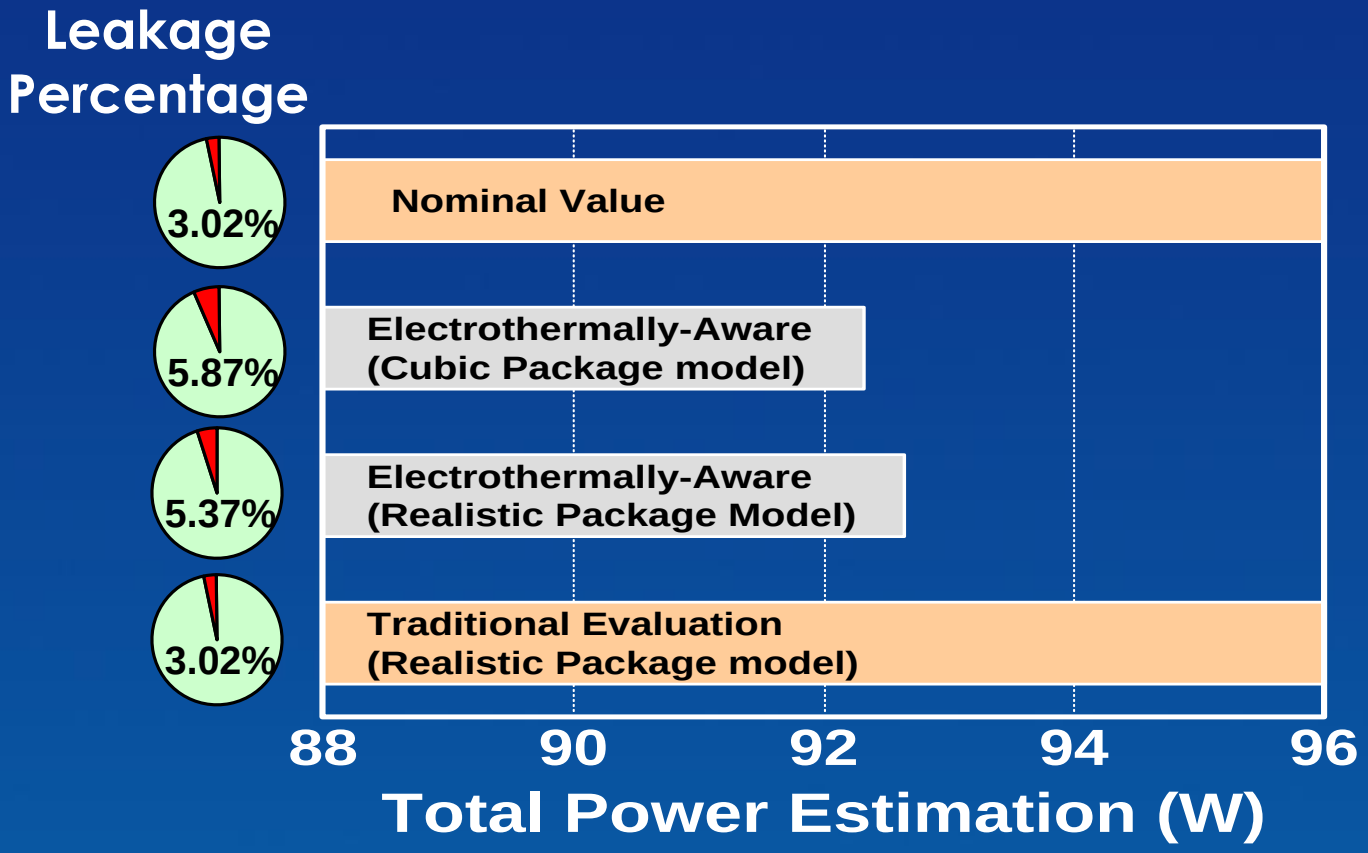


Realistic Package Thermal Model



- Simple cubic package thermal model ignores physical dimensions of different packaging layers and neglects lateral heat spreading
- Simple cubic model over-estimates the temperature profile

Implications for Power Estimation



- Power is not consistent with temperature in traditional evaluation
- Considering cubic package model overestimates leakage power

Design-Specific Metric Optimization

S-C. Lin and K. Banerjee, "A Design-Specific and Thermally-Aware Methodology for Trading-Off Power and Performance in Leakage-Dominant CMOS Technologies," TVLSI Vol. 16, No. 11, pp. 1488-1498, 2008.

Target:

Find a minimal value of Energy-Delay-Product for operation.

M. Horowitz, 1997

Delay

Delay of various gates in the critical path remains proportional to the delay of an equivalent inverter.

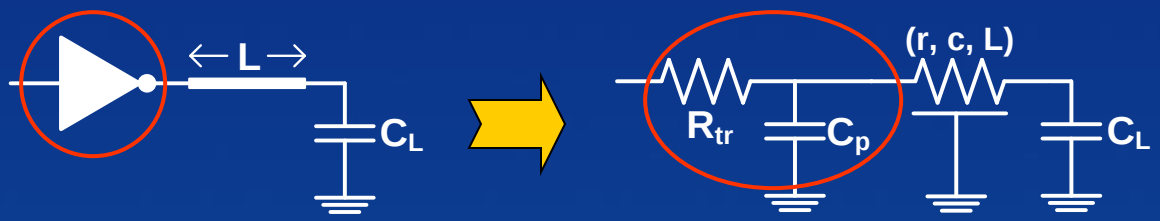
Can be evaluated by Alpha-Power model

T. Sakurai and A. R. Newton, 1990

Energy

Can be calculated by total power dissipation

Incorporate Interconnect Effects in EDP Optimization



$$\tau = R_{tr}(C_p + C_L + cL) + rLC_L + (\tfrac{1}{2})rcL^2$$

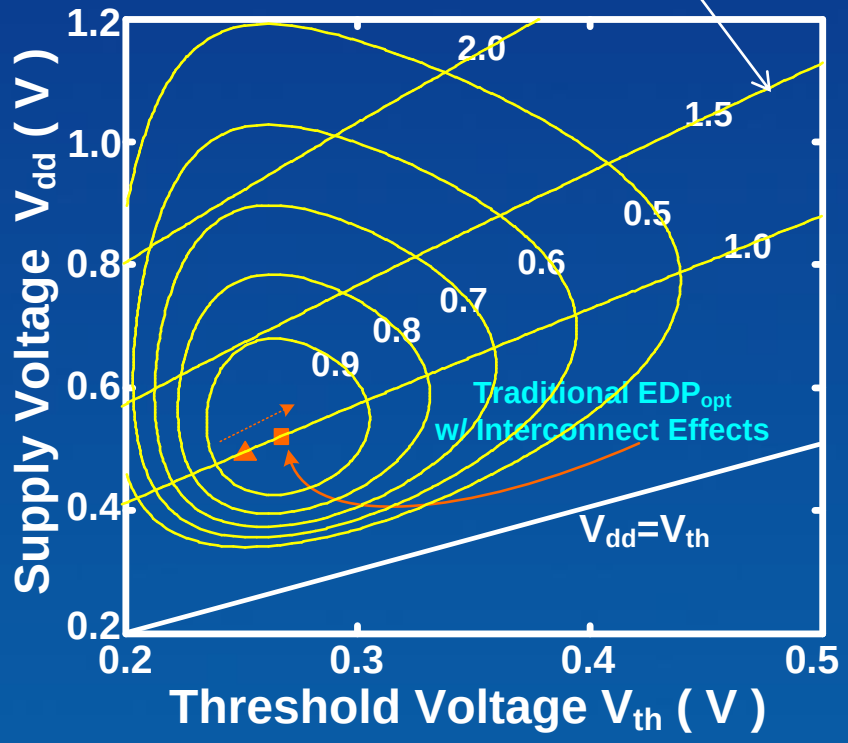
$$T_g \cong 0.69R_{tr}(C_p + C_L + cL) + 0.69rLC_L + 0.38rcL^2$$

$$T_g \cong \frac{KV_{dd}}{(V_{dd} - V_{th})^{\alpha}}\left[1 + \frac{cL}{C_p + C_L}\right] + 0.69rLC_L + 0.38rcL^2$$

$$P_{dynamic} = aC_{eff}V_{dd}^2F$$

$$P_{static} = I_s e^{-V_{th}/\gamma V_o}(1 - e^{-V_{ds}/\gamma V_o})W_{eff}V_{dd}$$

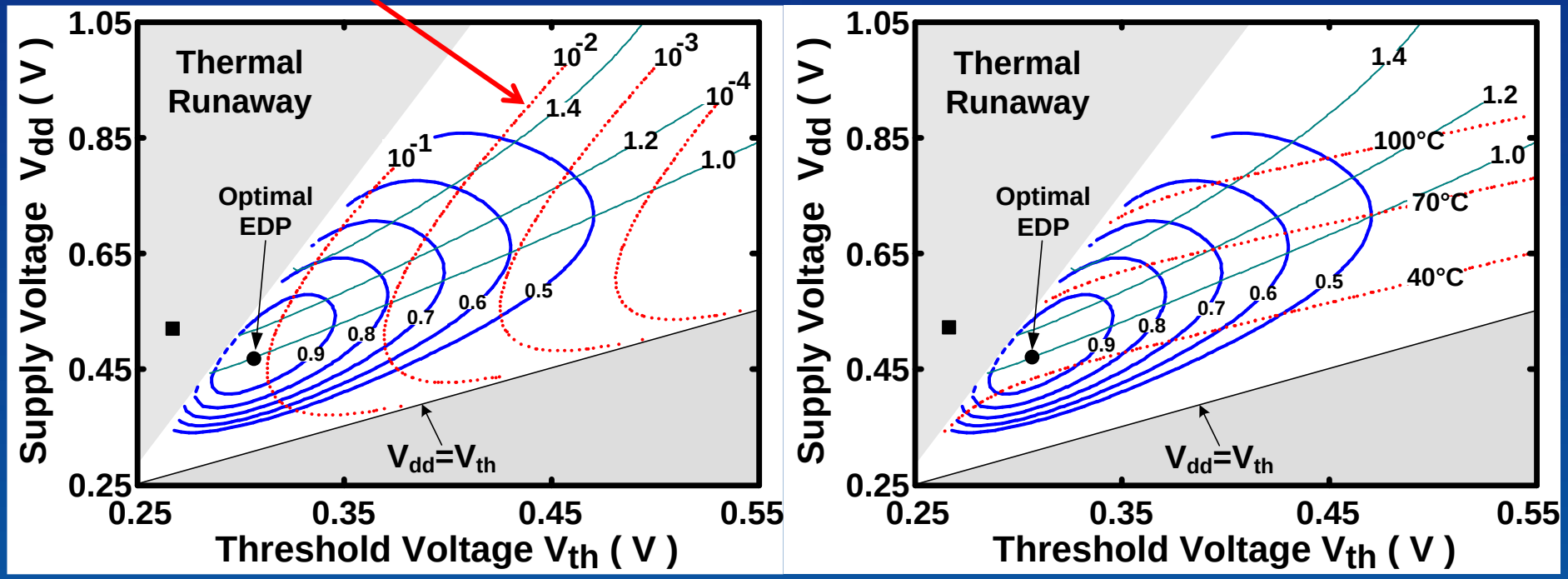
$$Energy = (P_{dynamic} + P_{static}) \cdot T_g L_d$$



EDP contours: 0.5 implies EDP = 2 EDP_{opt}

Electrothermally-Coupled EDP

Iso-leakage curves: leakage-power/total-power



Lin et al., TVLSI 2008

- A shift in optimal point, EDP and performance contours
- An overall change in shape of EDP contours
- Iso-temperature curves generated using self-consistent methodology– provide additional thermal (or reliability) constraint
- Operation region restricted by electrothermal constraints

Generalized Metric for Optimization

- EDP is not the only metric
- Other Metrics……

EDP is Energy X Delay = PT^2
PDP is Power X Delay = PT
PEP is Power X Energy = P^2T

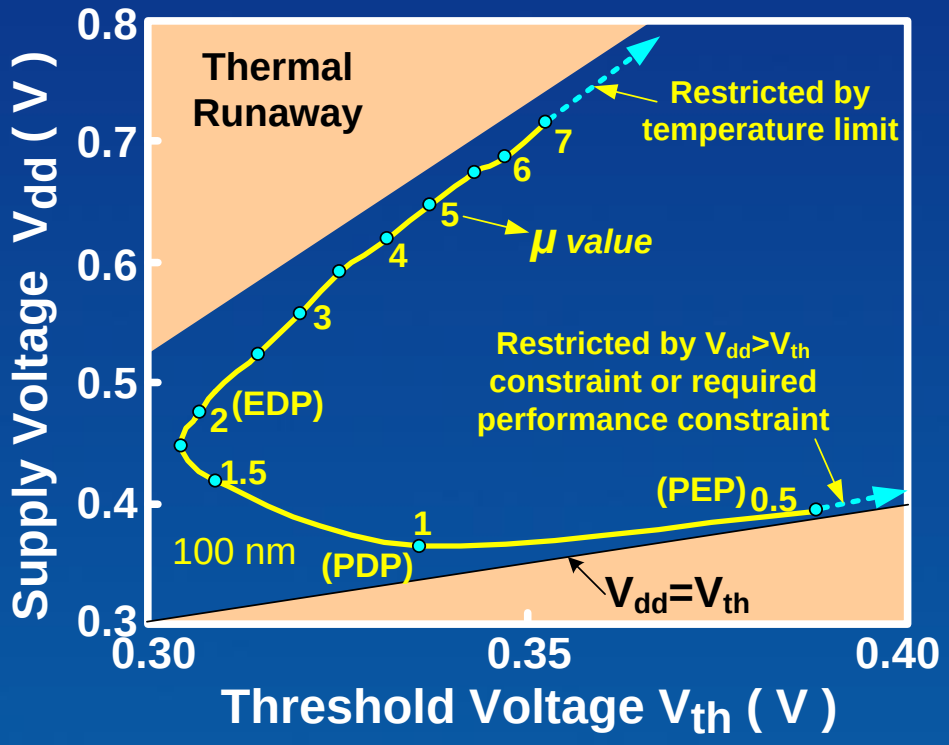
Generalized Metric: PT^{μ}

μ is the ratio of the exponent of delay over that of power ($\mu = 2$ for EDP)

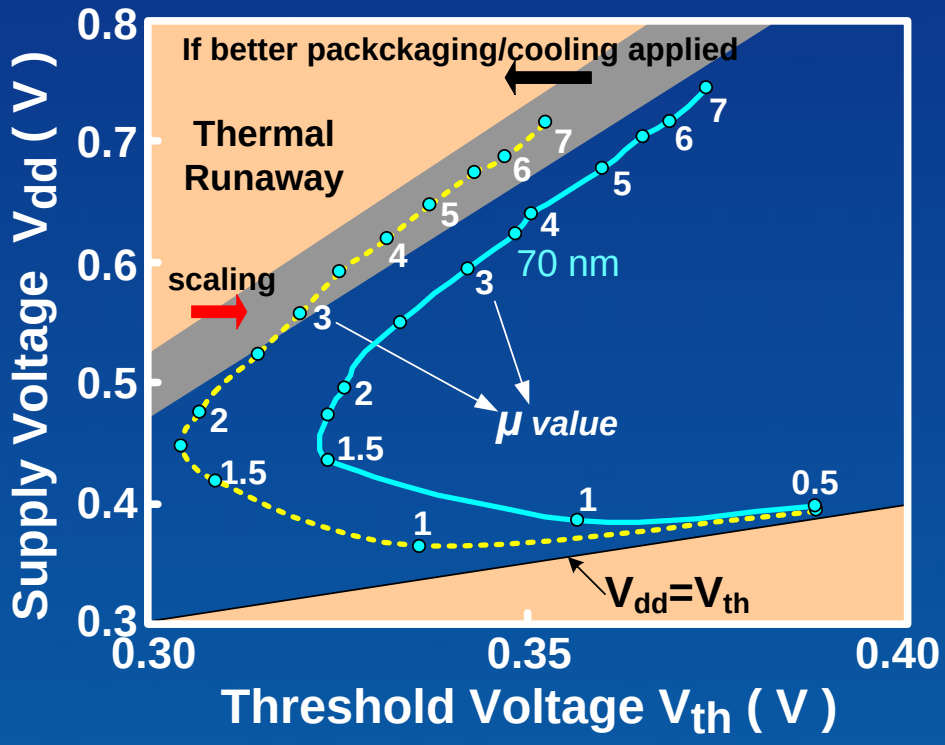
How to choose a design-specific metric ?

Optimal Operation Locus

Optimal operation locus for 100 nm node

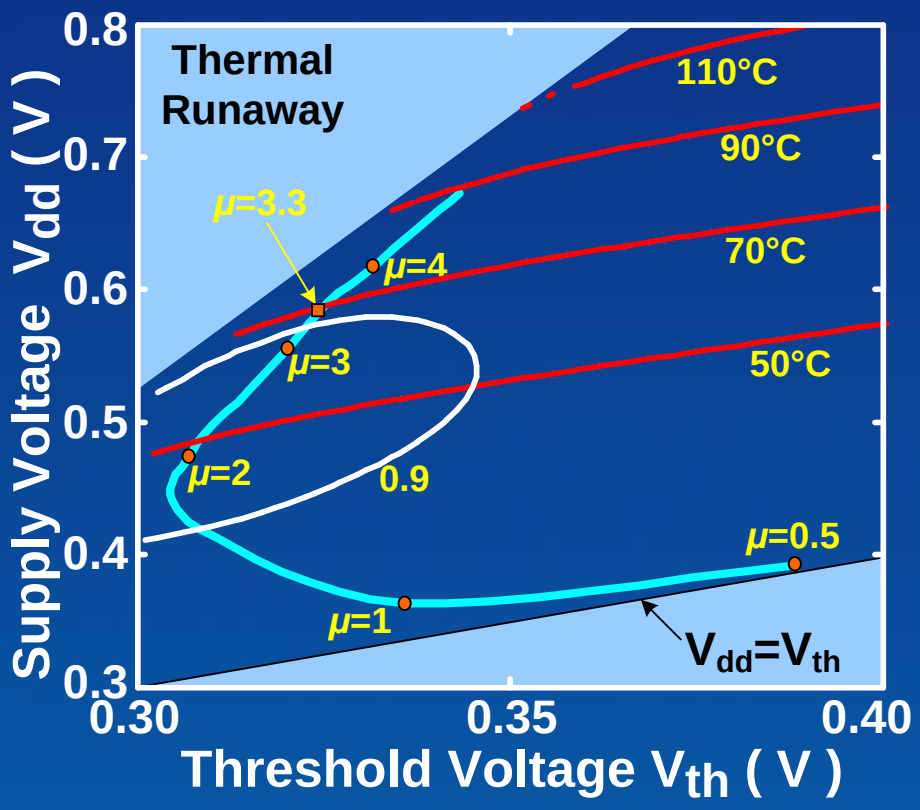


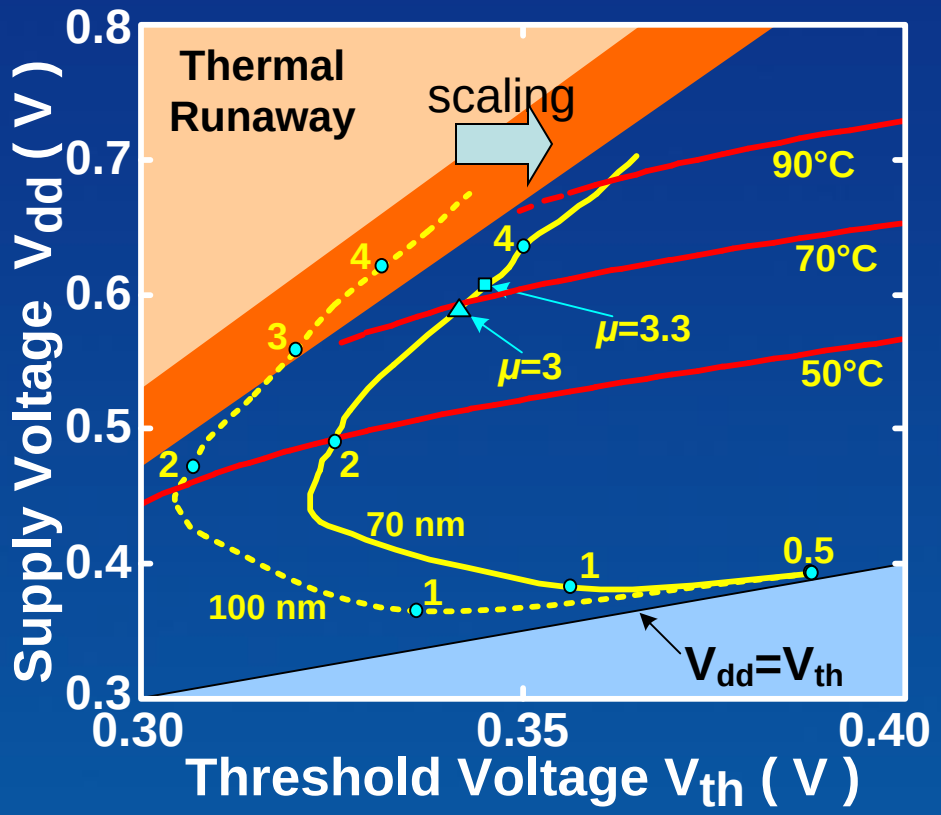
Effect of scaling on optimal operation locus



μ is determined by thermal and performance requirements

Thermal/Packaging Aware Design Optimization





- Choose an optimization metric to meet thermal/packaging requirements (For T = 70 C, μ = 3.3)
- Impact of scaling should be taken into account (For T = 70 C, μ =3)

IC Cooling for Power/Thermal Management?

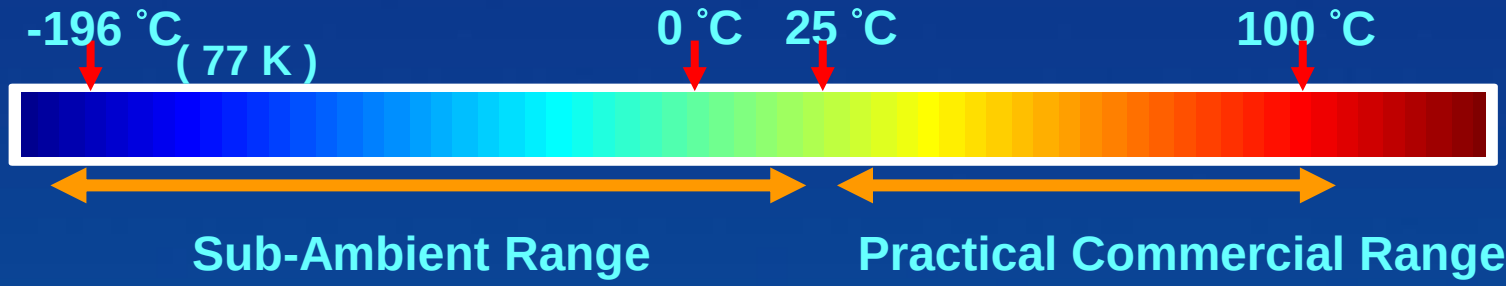
S-C. Lin and K. Banerjee, "Cool Chips: Opportunities and Implications for Power and Thermal Management," TED Vol. 55, No. 1, pp. 245-255, Jan 2008.

Efforts on Low-Power…..without hurting performance …

- Device Engineering
  - **Enhanced Channel Mobility – Strained Silicon**
  - **Reduced Gate Leakage – High-K Gate**
  - **Reduced Junction Leakage – Nitrogen Doped**
- Circuit Level
  - **Adaptive body-biasing, Dual V_{DD}-CMOS, Dual-V_{th}**
  - **Sleep Transistor, Clock/Power Gating**
- Micro-Architecture Level
  - **Multi-Core**

Does IC Cooling Make Sense?

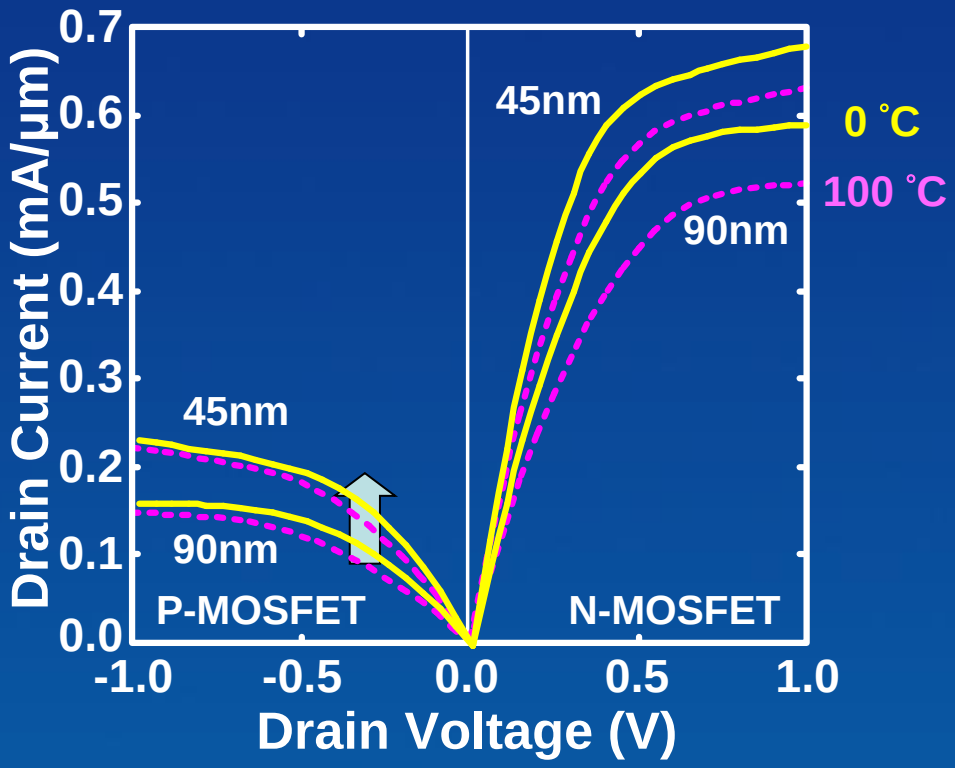
- Range of IC Cooling

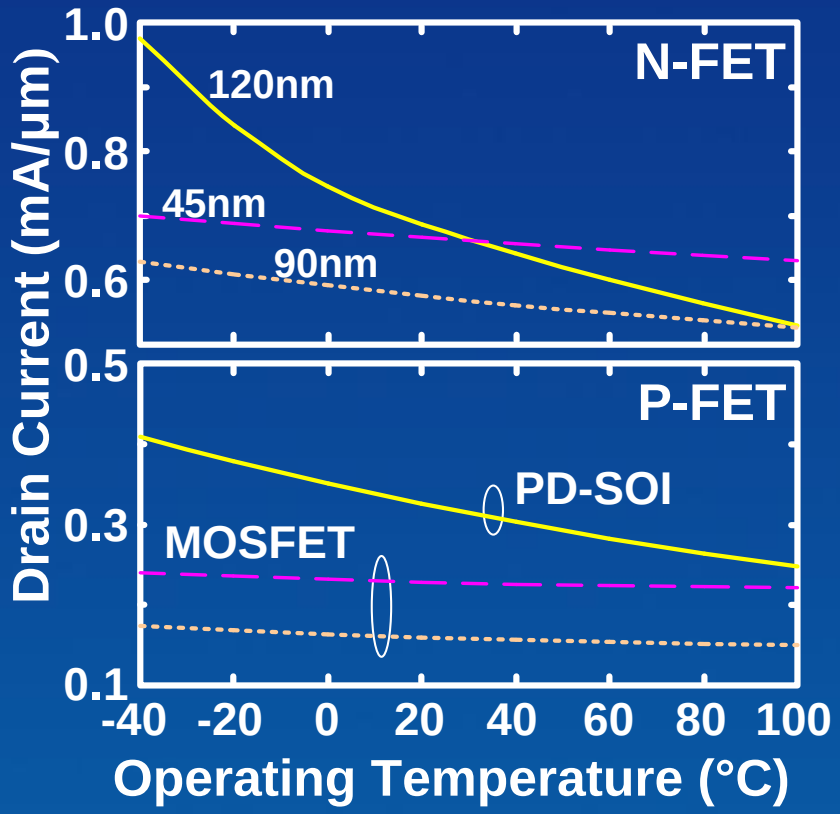


- Prior Research on Cooling
  - Analysis under Cryogenic Condition
    - Operating near liquid nitrogen temperature (77 K) requires complex cooling facilities
    - NOT for commercial purpose
  - Analysis of Performance under Cooling
    - Does NOT consider electrothermal couplings
    - Does NOT consider the system level power dissipation

Cooling---Benefit at the Device Level

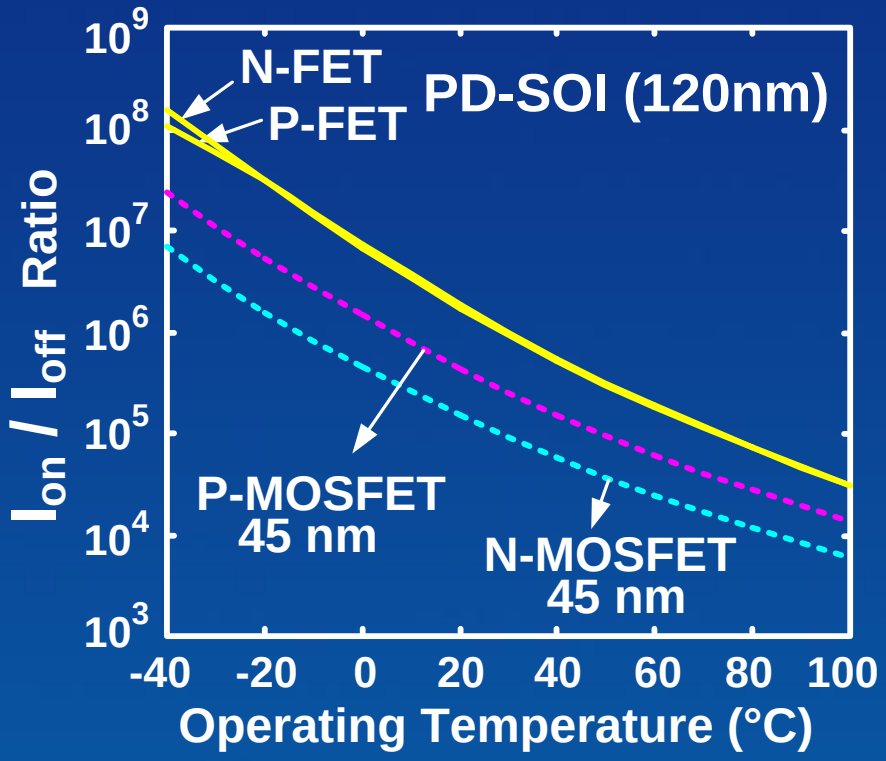
Transistor Drive Current Increases

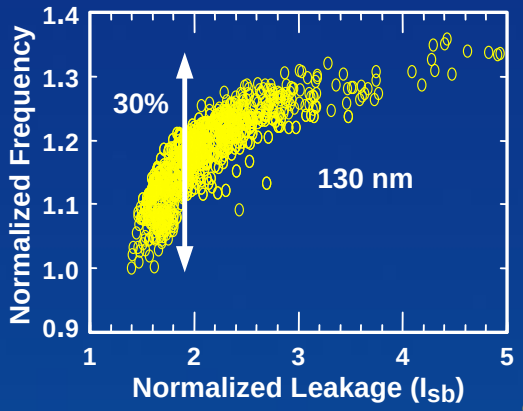




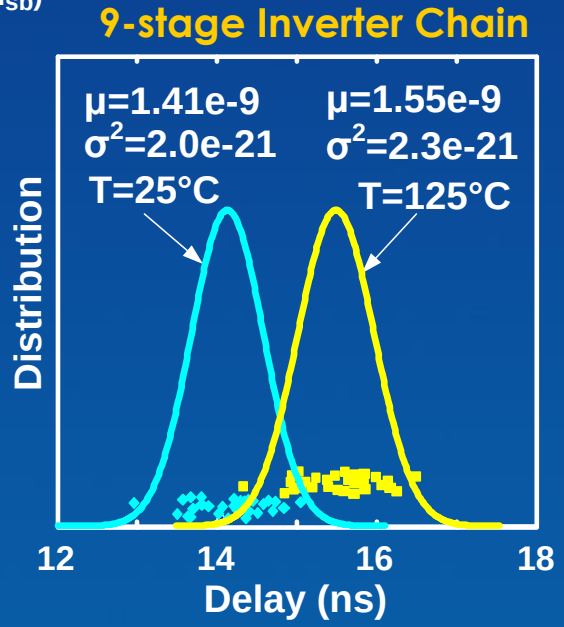
Higher drive current can be achieved by cooled operation across all technology nodes due to higher carrier mobility

Cooling---Benefit at the Circuit Level



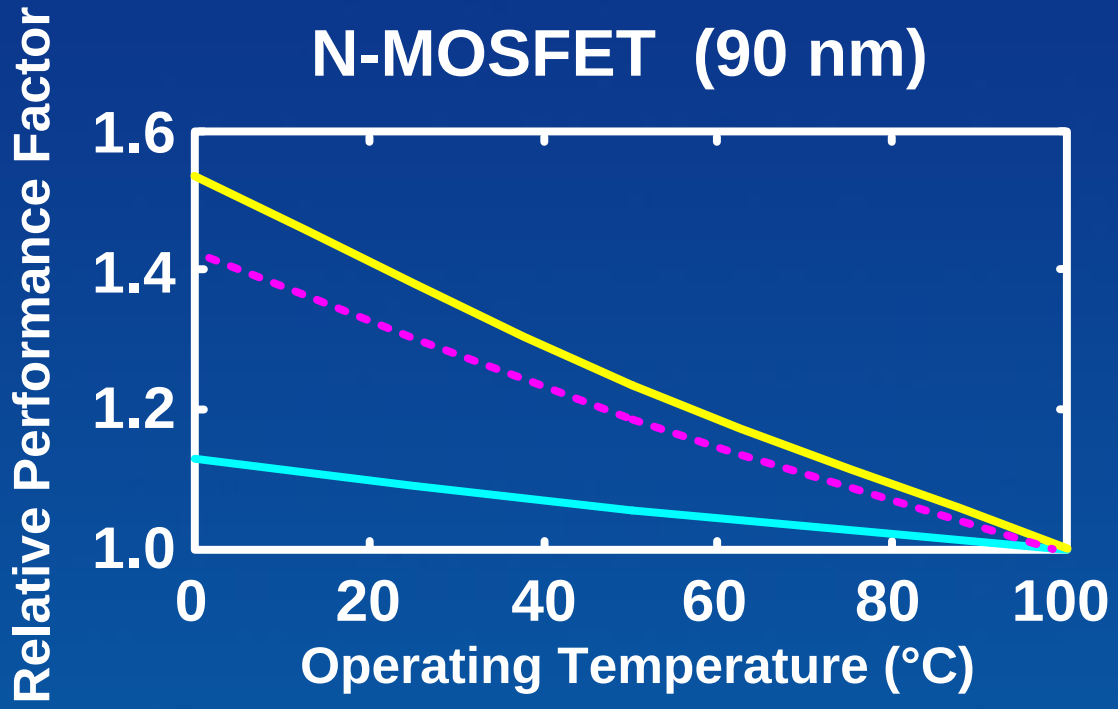


S. Borkar, Intel



- Enhance I_{on} to I_{off} ratio
- Reduce propagation delay and variance
- Benefit back-end performance and reliability

Further Exploiting the Benefit of Cooling



I. Aller et al., ISSCC 2000

Same Device

Same V_{th}

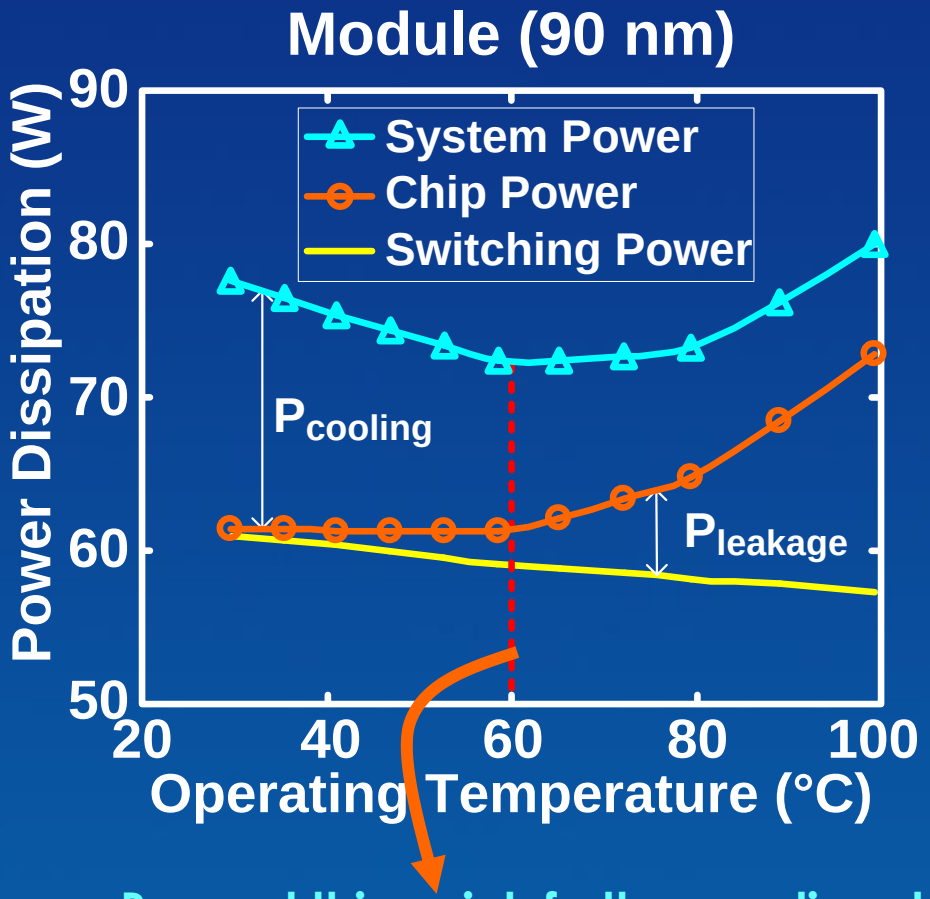
Applying Forward Body Bias (FBB)

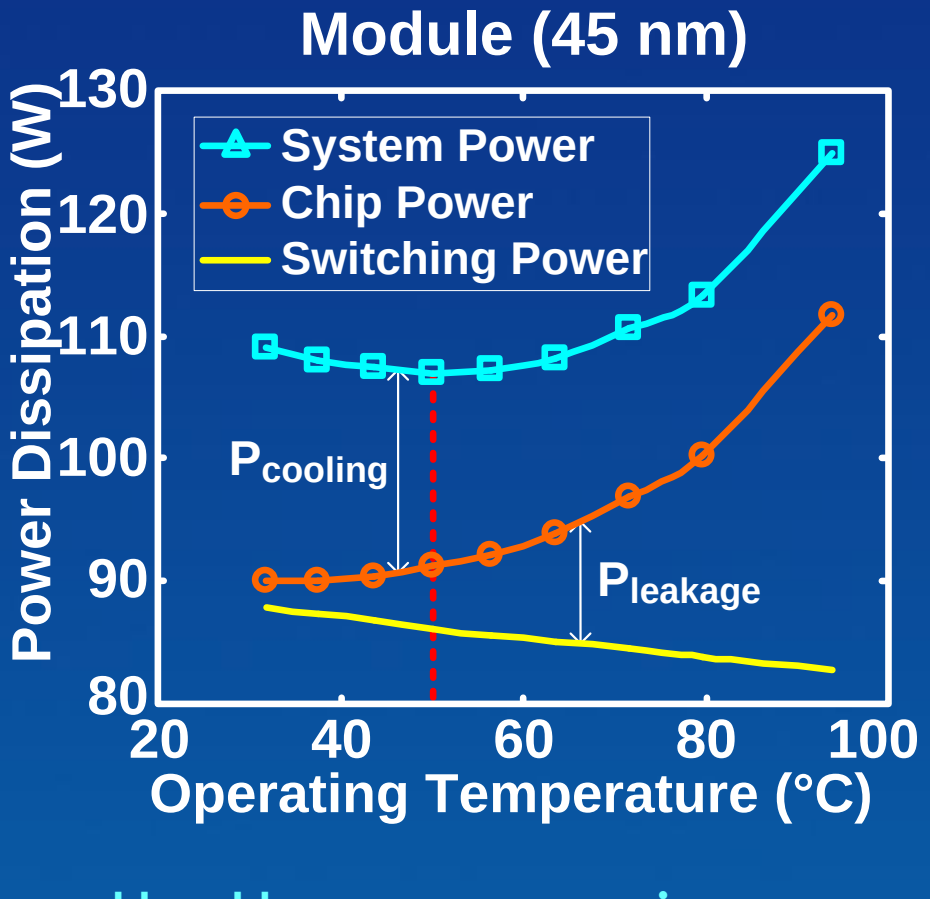
Same Leakage

Increase FBB Further

Performance can be further improved by different design strategies

Cooling---System Level Considerations

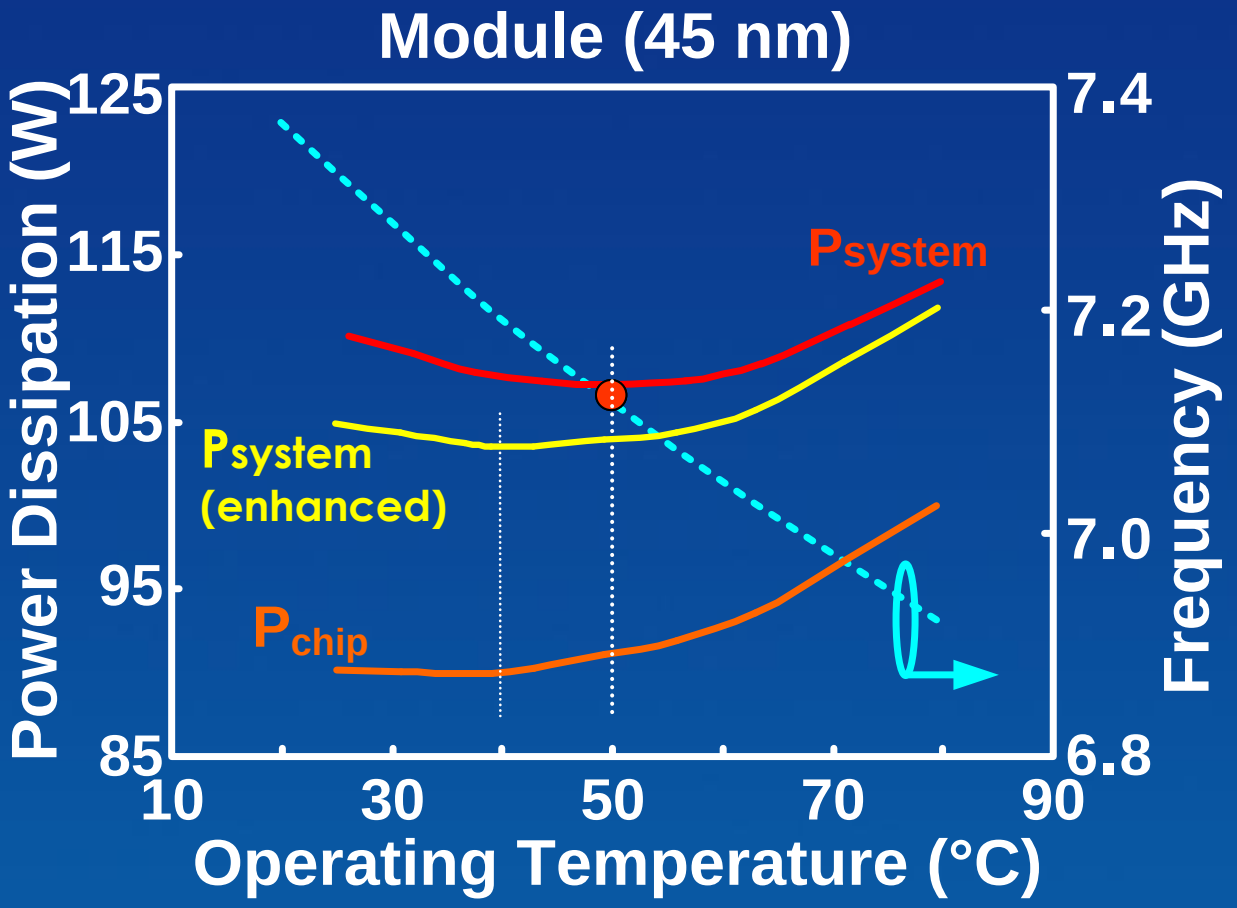




Beyond this point, further cooling does not lead to any power saving.

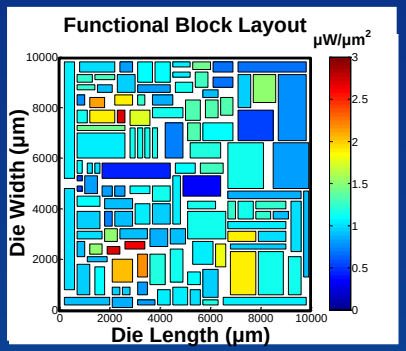
The limit occurs at a lower temperature as technology scales.

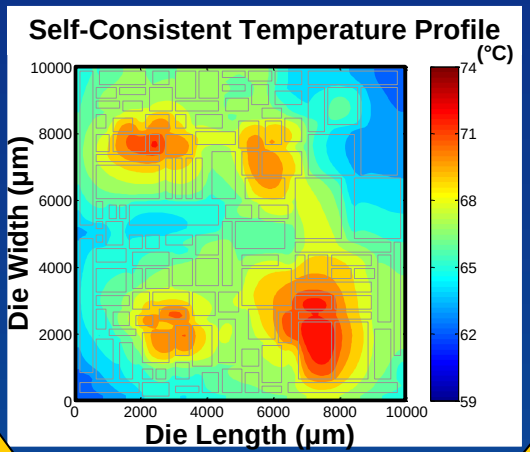
Extending the Practical Limit of Cooling



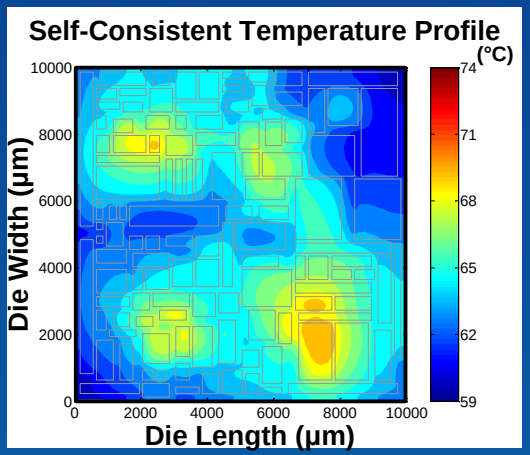
Practical limit can be further extended towards a lower temperature and higher performance is achieved by enhancing cooling efficiency

Hot-Spot Management



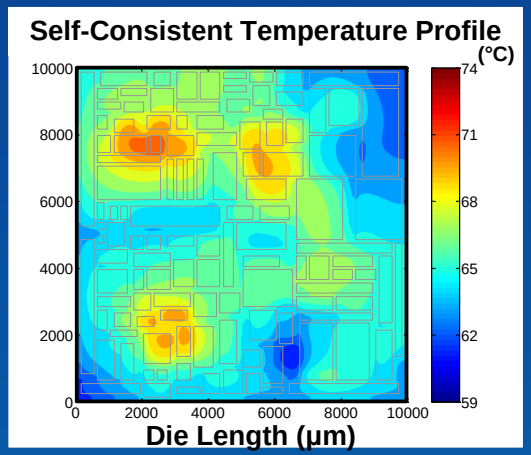


T_{MAX} decreases
but hot-spots remain



Global Cooling

Thermal resistance reduces 20%



Localized Cooling

Localized cooling will be more effective for hot-spot management

Conclusion

- For power/thermal management of nanoscale CMOS ICs, **electrothermal couplings** must be incorporated for trading-off chip-level power, performance, reliability, and cooling cost.
- An accurate leakage-aware **self-consistent** power and silicon-substrate **temperature-profile-estimation** technique has been developed for nanoscale CMOS technologies.
- A systematic methodology for power-performance optimization has been developed to **bring design and packaging closer**.
- **Chip cooling** combining device, circuit, and system level considerations can extend CMOS scaling.

Additional Issues….

- Extend CMOS scaling
  - Time per node can be expanded via cooling
- Application Based
  - High-performance servers
  - Hand-held applications
- Implications for Ultra Low-Voltage Applications
  - Positive Temperature Dependence